



PATENT

Attorney Docket No.: SAM-0526

Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al*

Serial No.: 10/796,507

Filing Date: March 9, 2004

Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR SUBSTRATES  
(As Amended)

Examiner: El Arini, Zeinab

Group Art Unit: 1746

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10/11/06  
Date

C. Harris  
Christina Harris

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Amendment Transmittal with Petition for 1-Month Extension of Time;
2. Amendment C in response to Office Action mailed on June 13, 2006;
3. Check in the amount of \$120.00 to cover 1-Month Extension of Time; and
4. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

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